



AP (JFW)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Daniel R. Caldwell, et al. Docket No: TI-36721  
Serial No: 10/706,762 Conf. No: 7834  
Examiner: Dung V. Nguyen Art Unit: 3723  
Filed: 11/10/2003  
For: CHEMICAL MECHANICAL POLISHING SLURRY PUMP MONITORING SYSTEM AND METHOD

**NOTICE OF APPEAL FROM THE PRIMARY EXAMINER  
TO THE BOARD OF APPEALS**

Mail Stop AF  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8(a)  
I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 6-24-05.

  
Ann Trent


Dear Sir:

Applicants hereby appeal to the Board of Appeals from the decision of the Primary Examiner mailed March 25, 2005, finally rejecting Claims 1-20.

The item(s) checked below are appropriate:

1. ☐ An extension of time to respond to the final rejection  
☐ was granted on \_\_\_\_\_.  
☐ is requested for \_\_\_\_ month.
2. ☒ A timely response to the final rejection has been filed.
3. ☒ Fee \$500.00:  
☐ Not required (Fee paid in prior appeal)  
☒ The Commissioner of Patents is hereby authorized to charge any fees which may be required or credit any overpayment to the deposit account of Texas Instruments Incorporated, Account No. 20-0668.

Texas Instruments Incorporated  
P.O. Box 655474, MS 3999  
Dallas, TX 75265  
(972) 917-4258

  
Peter K. McLarty  
Attorney for Appellants  
Reg. No. 44,923

06/28/2005 RHEBRHT 00000021 200668 10706762  
01 FC:1401 500.00 DA